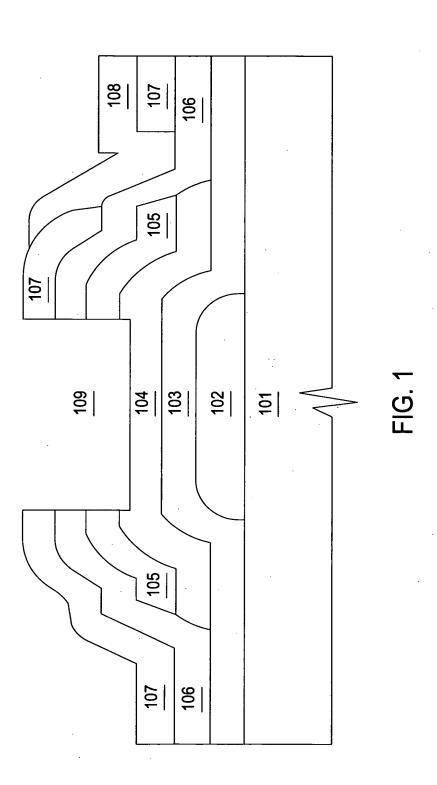
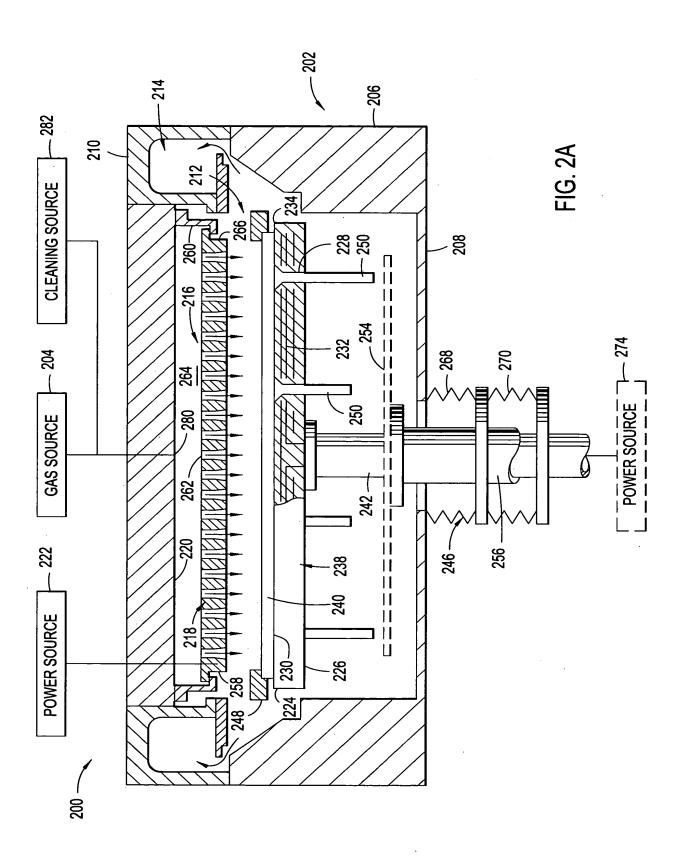
Atty Dkt. No. AMAT/8657/DISPLAY/AKT/RKK
Filed: Herewith
Applicant: Choi, et al.
Title: GAS DIFFUSION SHOWER HEAD DESIGN
FOR LARGE AREA PLASMA ENHANCED
CHEMICAL VAPOR DEPOSITION
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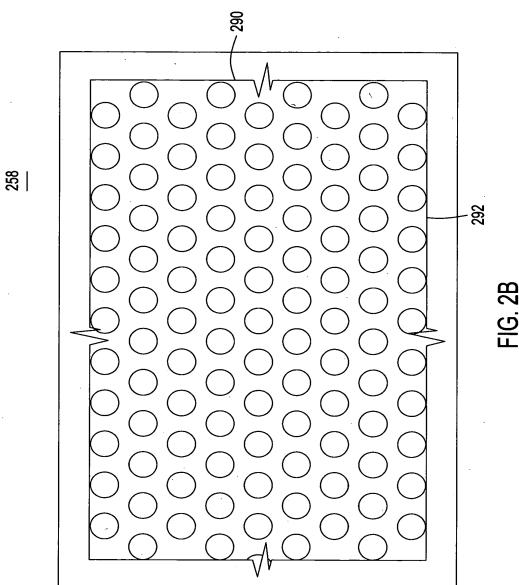
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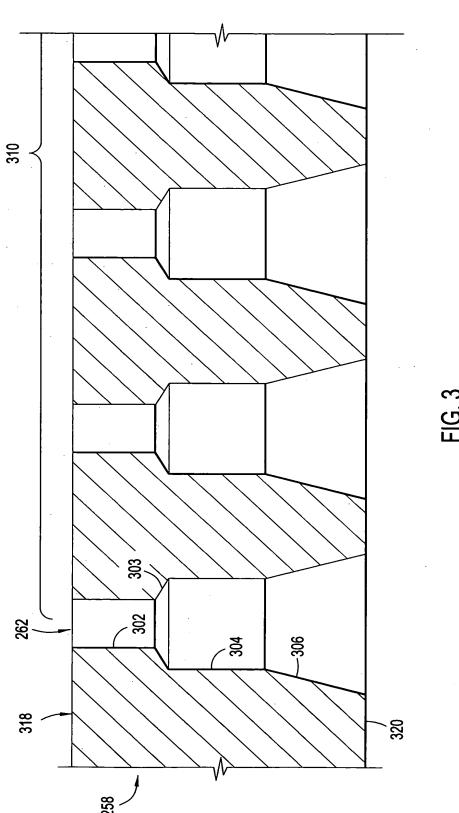
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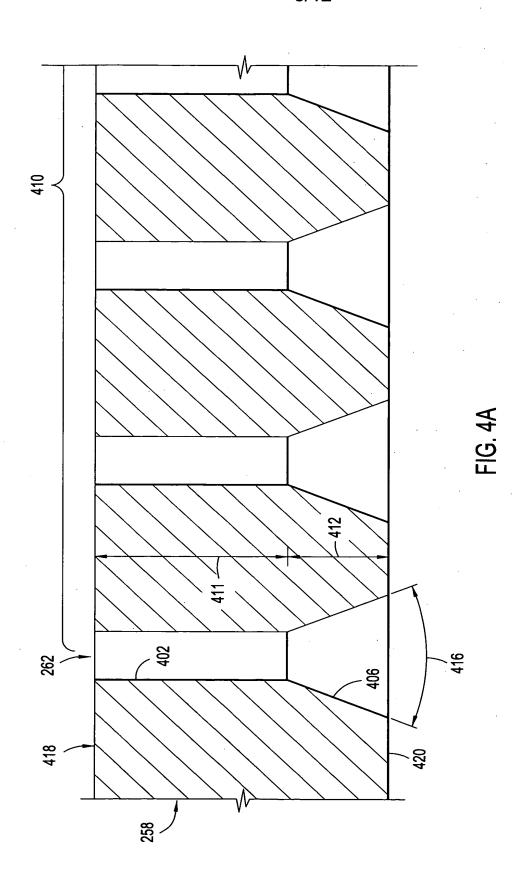
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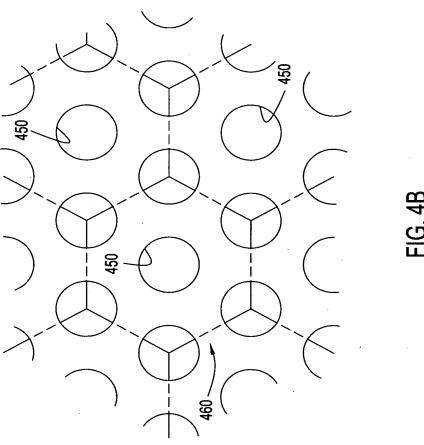


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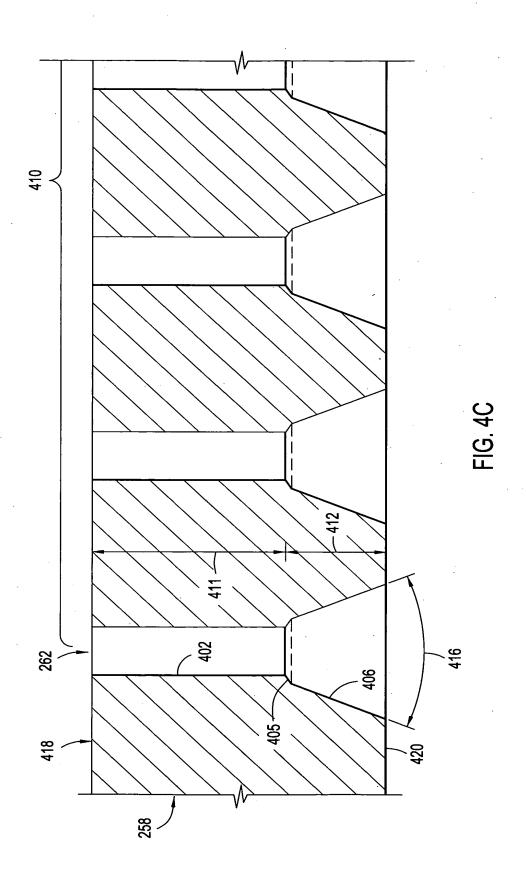


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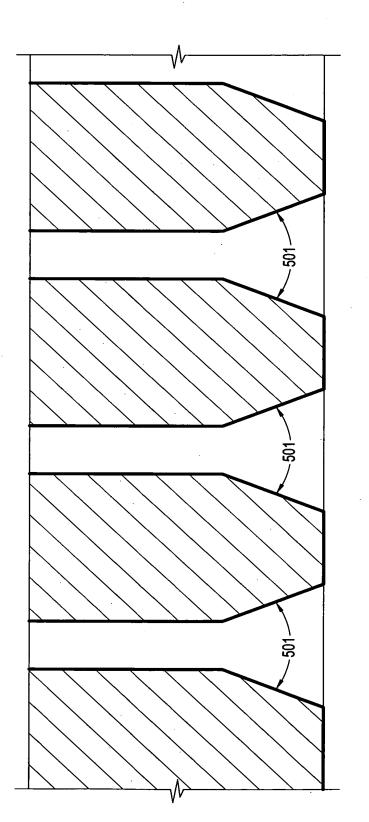
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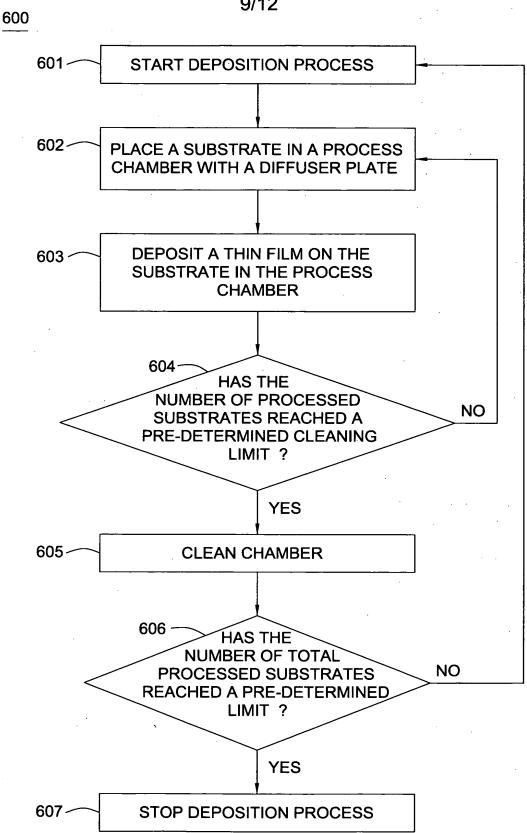


FIG. 6

 $\Gamma$ 

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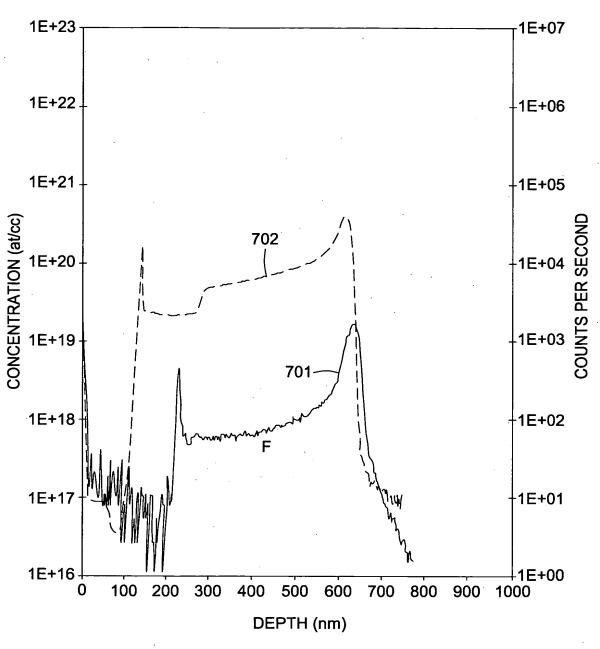
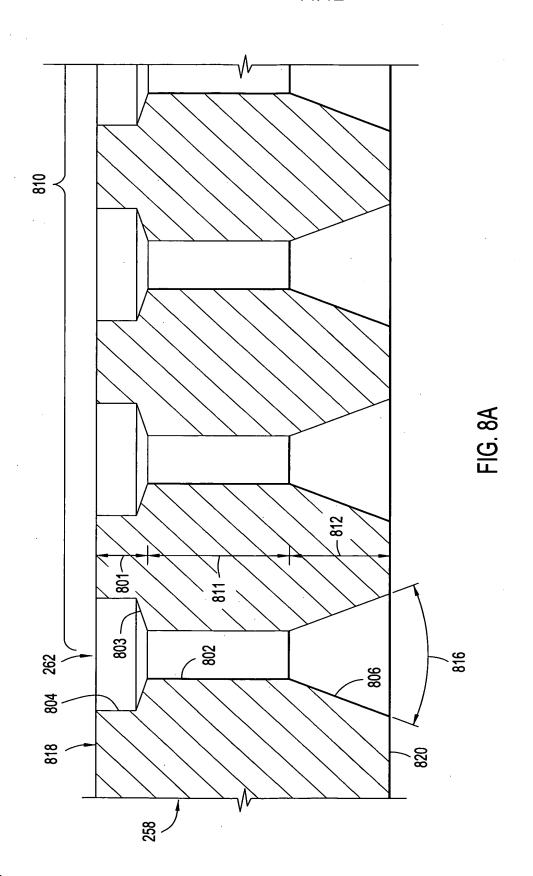


FIG. 7

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